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PERFORMANCE OF MULTILAYER CERAMIC ACTUATOR BY CONSIDERING THE SHAPE EFFECT

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Abstract

In the present study,the piezoelectricity and polarization of multilayer ceramic actuator, being designed to stack PMN-PZ-PT ceramic layers and Ag-Pd electrode layers alternatively, were investigated under a consideration of geometric factor, the volume ratio of the ceramic to the electrode layers.

The actuators were fabricated by tape casting of 0.2Pb(Mg1/3Nb2/3)O3-0.38PbZrO3-0.42PbTiO3 followed by lamination and burnout & co-firing processes. The actuators of 10 10 0.62 mm3 in size were formed in a way that 60 200 m thick ceramics were stacked alternatively with 5 m thick electrode layer. Increases in polarization and electric field-induced displacement with thickness of the ceramic layer were attributed to change of 90o/180o domain ratio, which was affected by interlayer internal stress. The piezoelectricity and actuation behaviors were found to depend upon the volume ratio (or thickness ratio) of ceramic to electrode laye

Introduction

Recently, multilayer ceramic actuators (hereafter called MCA) have been extensively used in controlling moving electric machines such as micro-mirror, micro-sized machining tool, micro-pippets and so on [1]. The design of MCA has been carried out on a basis of low field piezoelectric constant of the piezoelectric materials. In practice, the high field-actuation behavior of the MCA was observed to be different from the calculated strain based on the piezoelectric constant [2]. According to previous studies [3, 4], bulk-type actuators subjected to relative high electric fields exhibited thelarger displacement than the value estimated from the d-coefficient measured using the resonance method.

Besides the piezoceramics' properties, the high field strain behavior and its related domain motion for MCA are also dependent upon the geometry. Theactuators are designed to stack the piezoelectric ceramic layer and electrode layer alternatively. In the MCA the electrode Ag-Pd layer exists as inactive part with strong elastic modulus and acts as a resistance to deformation of the actuator. On the actuation mode where an electric field is applied along one direction, the electrode layers tend to act a resistance to deformation along the direction and compression along perpendicular to the direction. Accordingly, the field-induced deformation is affected by the relative thickness of two ceramic and electrode layers.

The purpose of the present study is to understand electric-induced deformation of multilayer ceramic actuator with regard to the relative ceramic layer thickness. The electric and piezoelectric properties were investigated with a consideration of geometric factor, thickness fraction of ceramic to electrode layers.

Experimental Procedure

Ceramic powder used was 0.42PbTiO3-0.38PbZrO3-0.2Pb(Mg1/3Nb2/3)O3 (PT-PZ-PMN). Various thick green sheets were made by passing the slurry below a doctor blade and drying. By printing Ag-30Pd paste on the sheet, electrode layers were made in 10 10 mm2. The stacking of 10 layers was carried out. The actuators were poled at 3 kV/mm in an electric field at 120oC for 30min.

The basic piezoelectric coefficients d31, d33 and kp of the ceramic material (PZ-PT-PMN) used in the actuator were measured in a circular plate (diameter 18 mm, thickness 1mm) by the resonance method, using an impedance analyzer (HP 4194, Hewlett-Packard Co.), as listed in Table 1. The electric field-induced strain of the poled actuators was measured in the longitude direction, using a laser-based displacement measurement system (OFV 303 vibrometer scanning head, Polytech Co.) at room temperature.

Table 1. Piezoelectric and electric properties of the piezoelectric ceramics used.

D33 (pC/N)	d31 (pC/N)	Kp	Qm	Zr (at 1kHz)	33/o	E11 (GPa)
450	-230	0.58	75	196	2500	22 GPa

To analyze the deformation mechanism, in-situ XRD patterns were collected for the poled actuator under various electric field applications. The diffraction experiment was performed at an applied electric field of 2 kV/mm with step scanning at 45o, where (200) and (002) diffracted peaks are placed.

Composite Model

The multilayer actuator can be considered to be basically the same geometrical structure as composite. In the actuator, the ceramic layer and electrode layer are connected in series along x3 axis and in parallel along x1 axis,as shown in Figure 1. Since the two layers are in series along x3axis, they experience the same stress. This assumes that the two layers do not exert forces on one another and hence generate no internal stress. In the x3axis of the multilayer actuator, the interlayer stress must be taken into consideration. Thus, there are two contributions of d33 of the multilayer: those arising from electric field E3 along x3 direction and those arising from internal stress

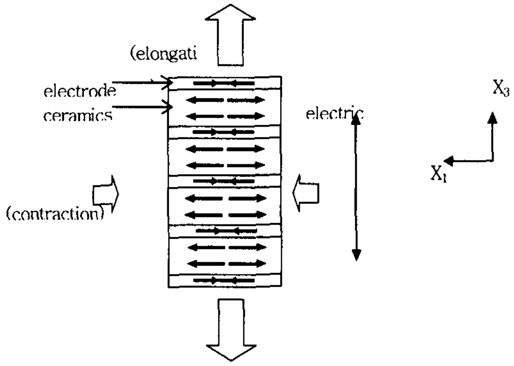

Fig. 1. Schematic diagram showing the internal stress configuration in the inner structure of multilayer actuator subjected to an electric field along x3 axis.

Considering only the external electric field E3, the displacement appearing along the polar direction is given by the following equation

P3=o33E3=o33(C)E3V(C) (1)

, where P3 is polarization along x3 axis, 33(C)the relative permittivity of ceramics, E3 the applied field along x3 axis, V(C) the volume fraction of ceramic layers.

However, if internal stress (i)1 is considered as shown in the figure 1, a correction factor should be included. The correction arises from piezoelectric d31 coefficient. Thus, the expression can be explained by,

P3'=o33(C)E3(C)V(C)+d31(i)1(C)V(C) (2)

, when the actuator is stretched along x3, it contracts along x1. This contraction is controlled by the elastic compliance. If the two constituents contract equally, an internal stress is generated. The magnitude of the internal stress can be estimated by assuming that the strains are equal along x1 (1(C) = 1(E)) and that the sum of internal stress over the actuator structure is zero

((i)V=(i)1(C)V(C)+(i)1(E)V(E)=0).

Under these assumptions, it can be shown that the internal stress on the ceramic layer is given by

(i)1(C)=-d31E3/(S11(C)+S11(E)V(C)/(E))

(3)

The internal stress (i)1(C)produces a piezoelectric effect by coupling through coefficient d31. If both the electric field E3 and the internal stress (i)1(C) are acting, the polarization along x3 is given by

P'3=o33(C)E3(C)V(C)-d312E3/(S11(C)/V(C) + S11(E)/V(E)) (4)

The first term on the right is the electric field induction contribution and the second term is caused by the internal stress contribution occurred between ceramic and electrode layers. Coefficient d33 of the actuator is given by

d33'=3/E3=Q33P'32/E3

=Q33(o33(C)E3V(C))2/E3[1-d312/{o33(C)(S11(C)+S11(E)V(C)/V(E))}]2

=d33(bulk)V(C)2[1-d312/{o33(C)(S11(C)+S11(E)V(C)/V(E))}]2 (5)

Experimental Results and Discussion

Figure 2 represents polarization vs. electric field curves of multilayer actuators, designed by various thick ceramic layers. As can be seen in the (a) (c), the actuators with the thicker ceramic sheet have the increased spontaneous polarization (Ps) from 23 C/cm2 for 60m-thick layer to 38 C/cm2 for 200m-thick layer.

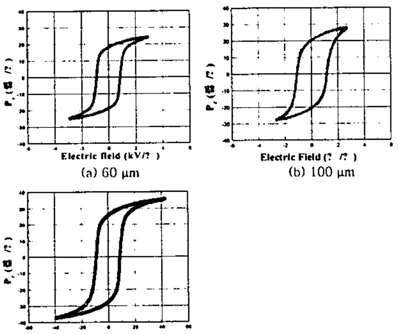

Fig. 2. Polarization vs. Electric field on the multilayer ceramic actuators with (a) 60 m, (b) 100 m, (c) 200 m thick-ceramic layers.

Figure 3 shows the X-ray patterns of the actuators after the sintering process and the reflected X-ray of (200) relative to (002). As can be seen in (a), only (200) peak was detected in zero-electricfield application. In order to observe the relationship [5] between the polarization process and domain switching in the actuator, the X-ray diffraction experiments of the actuators with various thick layers were carried out under an electric field application of 2 kV/mm and the results were shown in the Figure 3 (b) (d). In the case of the MC

with 60, 100 and 200 m-thick ceramic layers, the intensity ratio of X-ray peaks (002) to

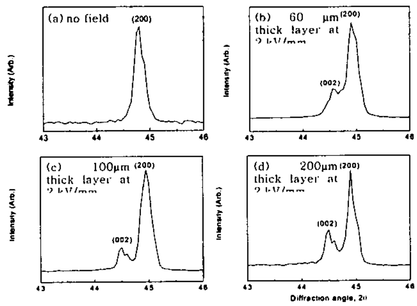

Fig. 3. (002) and (200) X-ray diffraction peaks taken on (a) the multilayer actuator without electric field application, and (b) 60m thick, (c) 100 m thick and (d) 200 m thick ceramic layer-actuators under an applied electric field of 2 kV/mm.

(200) under the electric field increases with the ceramic thickness, indicating the increased ration of 90o domain relative to 180o domain [6].

Figure 4 is the plots of strain vs.ceramic layer thickness of the MCAs subjected to electric fields of 300 and 600 V/mm. As can be seen in the figure, the MCA containing thick ceramic layer shows the larger strain.

It can be shown from Eg. (5) that d33 is considerably decreased due to internal stress and its resultant resistance to contraction along x1 and elongation along x3. The calculations were performed on a basis of the data listed in Table 1. The relative amount of 90o domain.

and to elongate along x1 axis. Decrease of d33 coefficient relative to bulk type specimen coefficient d33(bulk)is shown by the internal stress effect for the case of volume ratio of ceramic layer. Comparing the calculated with the experimental as shown in the Figure 5,

the spontaneous polarization and d33 as a function of ceramic volume (thickness) fraction is in fairly agreement with the measured values from the Figure 4.

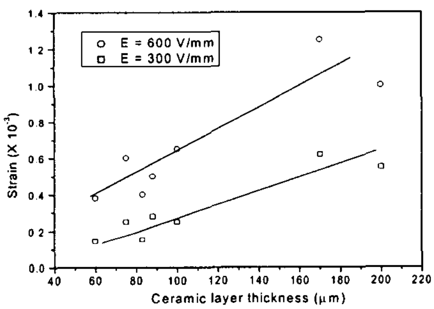

Fig. 4. Strain with respect to ceramic layer thickness of MCA subjected to electric fields of 300 and 600 V/mm.

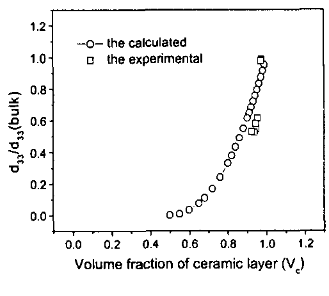

Fig. 5. Piezoelectric d33-coefficient ratio of multilayer actuator ceramics relative to bulk type as a function of volume fraction of ceramic layer in the MCA

Conclusions

The piezoelectricity and polarization of multilayer actuator were investigated under a consideration of stacking conditions including the thickness of the ceramic layer. The increase in polarization and electric field-displacement with thickness of the ceramic layer was attributed to the interlayer internal stress.

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